

Notice of References Cited

Application/Control No.

10/564,039

Applicant(s)/Patent Under
Reexamination
FUJIWARA ET AL.

Examiner

Nizal S. Chandrakumar

Art Unit

1625

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	F	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP-57088455	11-1980	JP	Yoshio et al.	CO3G 5/04
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	Q					
	R					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Bader et al. Proceedings of SPIE-The international Society for Optical Engineering, 2001, Vol. 4461, pages 304-310.
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	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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* Applicant provided